



PATENT  
8017-1122

IN THE U.S. PATENT AND TRADEMARK OFFICE

In re application of

Noriaki ODA

Conf. 2345

Application No. 10/761,204

Group 2826

Filed January 22, 2004

Examiner Alexander Williams

SEMICONDUCTOR DEVICE AND METHOD OF  
FABRICATION SAME

**AMENDMENT**

MS AMENDMENT

Commissioner for Patents

August 30, 2005

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

Responsive to the Official Action of June 30, 2005, for which the period for response has been extended one month, please amend the above-identified application as follows:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks** begin on page 7 of this paper.